## WHAT IS CLAIMED IS:

- A method of fabricating a micromechanical device, the method comprising:
   forming at least two micromechanical devices on a common substrate;
   applying a liquid overcoat material to said micromechanical devices;
   separating said common substrate to separate said devices; and
   removing said overcoat from said micromechanical devices.
- 2. The method of Claim 1, said applying a liquid overcoat material comprising: immersing said common substrate in a liquid overcoat material;
- 3. The method of Claim 1, said applying a liquid overcoat material comprising:

  applying said liquid overcoat material to said common substrate; and

  spinning said common substrate to disperse said liquid overcoat material.
- 4. The method of Claim 1, said applying a liquid overcoat material comprising: spraying said liquid overcoat material onto said common substrate.
- 5. The method of Claim 1, said applying a liquid overcoat material comprising:

  spraying said liquid overcoat material onto said common substrate using a low pressure spray.
- 6. The method of Claim 1, said applying a liquid overcoat material comprising:

  spraying said liquid overcoat material onto said common substrate using a high pressure spray.
- 7. The method of Claim 1, said applying a liquid overcoat material comprising:

  spraying said liquid overcoat material onto said common substrate using a low pressure pneumatic spray.
- 8. The method of Claim 1, said applying a liquid overcoat material comprising:

spraying said liquid overcoat material onto said common substrate using a high pressure pneumatic spray.

- 9. The method of Claim 1, said applying a liquid overcoat material comprising:

  nebulizing said liquid overcoat material using Meinhard nebulization; and

  spraying said nebulized liquid overcoat material onto said common substrate.
- 10. The method of Claim 1, said applying a liquid overcoat material comprising:

  nebulizing said liquid overcoat material using ultrasonic nebulization; and

  spraying said nebulized liquid overcoat material onto said common substrate.
- The method of Claim 1, said applying a liquid overcoat material comprising:

  dispensing droplets of said liquid overcoat material from a nozzle using a heated droplet dispenser; and

  depositing said droplets onto said common substrate.
- 12. The method of Claim 1, comprising: curing said liquid overcoat material.
- 13. The method of Claim 1, comprising:

  curing said liquid overcoat material by heating said liquid overcoat material.
- 14. The method of Claim 1, comprising:

  curing said liquid overcoat material using ultraviolet light.
- 15. The method of Claim 1, said applying a liquid overcoat material to said micromechanical devices comprising:

applying a urethane acrylate resin.

16. The method of Claim 1, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an epoxy acrylate resin.

17. The method of Claim 1, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an acrylate monomer.

18. The method of Claim 1, said removing said overcoat from said micromechanical devices comprising:

removing said overcoat using an isotropic etch.

19. A method of fabricating a micromechanical device, the method comprising:

forming at least two micromechanical devices on a common substrate;

immersing said common substrate in a liquid overcoat material to coat said

micromechanical devices;

separating said common substrate to separate said devices; and removing said overcoat from said micromechanical devices.

20. The method of Claim 19, comprising:

spinning said common substrate to disperse said liquid overcoat material.

21. The method of Claim 19, comprising:

curing said liquid overcoat material.

22. The method of Claim 19, said applying a liquid overcoat material to said micromechanical devices comprising:

applying a urethane acrylate resin.

23. The method of Claim 19, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an epoxy acrylate resin.

24. The method of Claim 19, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an acrylate monomer.

25. The method of Claim 19, said removing said overcoat from said micromechanical devices comprising:

removing said overcoat using an isotropic etch.

26. A method of fabricating a micromechanical device, the method comprising:

forming at least two micromechanical devices on a common substrate;
spraying a liquid overcoat material onto said common substrate to coat said
micromechanical devices;

separating said common substrate to separate said devices; and removing said overcoat from said micromechanical devices.

27. The method of Claim 26, comprising:

curing said liquid overcoat material.

28. The method of Claim 26, said applying a liquid overcoat material to said micromechanical devices comprising:

applying a urethane acrylate resin.

29. The method of Claim 26, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an epoxy acrylate resin.

30. The method of Claim 26, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an acrylate monomer.

31. The method of Claim 26, said removing said overcoat from said micromechanical devices comprising:

removing said overcoat using an isotropic etch.

32. A method of fabricating a micromechanical device, the method comprising:

forming at least two micromechanical devices on a common substrate;

nebulizing a liquid overcoat material;

spraying said nebulized liquid overcoat material onto said common substrate to coat said micromechanical devices;

separating said common substrate to separate said devices; and removing said overcoat from said micromechanical devices.

- 33. The method of Claim 32, said nebulizing said liquid overcoat material comprising: nebulizing said liquid overcoat material using Meinhard nebulization.
- 34. The method of Claim 32, said nebulizing said liquid overcoat material comprising: nebulizing said liquid overcoat material using ultrasonic nebulization.
- 35. The method of Claim 32, comprising: curing said liquid overcoat material.
- 36. The method of Claim 32, said applying a liquid overcoat material to said micromechanical devices comprising:

applying a urethane acrylate resin.

37. The method of Claim 32, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an epoxy acrylate resin.

38. The method of Claim 32, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an acrylate monomer.

39. The method of Claim 32, said removing said overcoat from said micromechanical devices comprising:

removing said overcoat using an isotropic etch.

40. A method of fabricating a micromechanical device, the method comprising:

forming at least two micromechanical devices on a common substrate;

dispensing droplets of a liquid overcoat material from a nozzle using a heated

droplet dispenser;

depositing said droplets onto said common substrate to coat said micromechanical devices;

separating said common substrate to separate said devices; and removing said overcoat from said micromechanical devices.

41. The method of Claim 40, comprising:

curing said liquid overcoat material.

42. The method of Claim 40, said applying a liquid overcoat material to said micromechanical devices comprising:

applying a urethane acrylate resin.

43. The method of Claim 40, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an epoxy acrylate resin.

44. The method of Claim 40, said applying a liquid overcoat material to said micromechanical devices comprising:

applying an acrylate monomer.

45. The method of Claim 40, said removing said overcoat from said micromechanical devices comprising:

removing said overcoat using an isotropic etch.